

DOCKET NO: 283485US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
MASATOMO SUMIYA, ET AL. : EXAMINER: LANGMAN, JONATHAN C.
SERIAL NO: 10/562,265 :
FILED: MAY 24, 2006 : GROUP ART UNIT: 1794
FOR: METHOD FOR GROWING THIN :
NITRIDE FILM ONTO SUBSTRATE AND :
THIN NITRIDE FILM DEVICE :

RESPONSE TO THE REQUIREMENT FOR RESTRICTION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Requirement for Restriction mailed November 14, 2008, Applicants elect, with traverse, Group I: Claims 1-4 drawn to a method.

Applicants request that the Examiner expand the search to the non-elected claims of Group II, Claims 5-7, if the elected Group I claims are found allowable.

Remarks/Arguments begin on page 2 of this paper.